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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Confirmation No.: 5700

Katsuhiko Miya, et al.

Date: May 14, 2007

Serial No.: 10/659,213

Group Art Unit: 1746

Filed: September 10, 2003

Examiner: Jason Mark Heckert

For: SUBSTRATE PROCESSING APPARATUS

VIA EFS-WEB

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

AMENDMENT/SUBMISSION

Sir:

This is a response to the Final Office Action mailed February 13, 2007 in the above-identified application. Reconsideration of the application is respectfully requested.

FEE CALCULATION

Any additional fee required has been calculated as follows:

_____ If checked, "Small Entity" status is claimed.

	NO. CLAIMS AFTER AMENDMENT		HIGHEST NO. PREVIOUSLY PAID FOR		EXTRA PRESENT		RATE	ADDIT. FEE
TOTAL	35	MINUS	36	* =	0	X	(\$25 SE or \$50)	\$-0-
INDEP.	8	MINUS	4	** =	4	X	(\$100 SE or \$200)	\$800.00
FIRST PRESENTATION OF MULTIPLE DEPENDENT CLAIM						X	(\$180 SE or \$360)	\$-0-
								TOTAL \$800.00

* not less than 20 ** not less than 3

If any additional payment is required, credit card payment in the amount of \$800.00 is submitted via EFS-WEB.